

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

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For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A  
NICKEL SALICIDE PROCESS**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This paper is being filed in response to the Final Office Action dated April 3, 2007.

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